

Inventor Information

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| Inventor One Given Name:: | Yoshiro |
| Family Name:: | SHIOKAWA |
| City of Residence:: | Hachioji-shi |
| Country of Residence:: | JAPAN |
| Citizenship Country:: | JAPAN |
| Inventor Two Given Name:: | Megumi |
| Family Name:: | NAKAMURA |
| City of Residence:: | Fuchu-shi |
| Country of Residence:: | JAPAN |
| Citizenship Country:: | JAPAN |
| Inventor Three Given Name:: | Tohru |
| Family Name:: | SASAKI |
| City of Residence:: | Fuchu-shi |
| Country of Residence:: | JAPAN |
| Citizenship Country:: | JAPAN |
| Inventor Four Given Name:: | Toshihiro |
| Family Name:: | FUJII |
| City of Residence:: | Hamura-shi |
| Country of Residence:: | JAPAN |
| Citizenship Country:: | JAPAN |

Correspondence Information

| | |
|----------------------------------|----------------------|
| Correspondence Customer Number:: | 25944 |
| Name Line One:: | Oliff & Berridge PLC |
| Address Line One:: | P.O. Box 19928 |
| City:: | Alexandria |
| State or Province:: | VA |
| Postal or Zip Code:: | 22320 |
| Telephone:: | (703) 836-6400 |
| Fax:: | (703) 836-2787 |
| Electronic Mail:: | commcenter@oliff.com |

Application Information

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|------------------------|------------------------------|
| Title Line One:: | METHOD AND APPARATUS FOR ION |
| Title Line Two:: | ATTACHMENT MASS SPECTROMETRY |
| Total Drawing Sheets:: | 10 |
| Docket Number:: | 109675 |

Prior Foreign Applications

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|---------------------------|--------------|
| Foreign Application One:: | 2000-169644 |
| Filing Date:: | June 6, 2000 |
| Country:: | JAPAN |
| Priority Claimed:: | YES |

Assignee Information

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|-----------------------------|-----------------------|
| Name of assignee:: | ANELVA CORPORATION |
| Assignee Address Line One:: | 8-1, Yotsuya 5-chome, |
| City:: | Fuchu-shi |
| State or Province:: | Tokyo |
| Country:: | JAPAN |